

10/PRTS

10/537124

JG17 REC'D PCT/PTO 02 JUN 2005

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Description

Circuit Layout Configuration

5 Technical Field

This invention relates to a circuit layout configuration, for example, a circuit layout configuration to improve matching characteristics of a transistor pair in a circuit having the transistor pair such as a current mirror circuit and a differential amplifier.

10 Background Art

Close matching between the transistors is important for the configuration of the current mirror circuit and of the differential amplifier. In particular, the close matching helps in obtaining a low offset operational amplifier. Fig. 7 is a circuit diagram showing a differential gain stage. A pair of MOS transistors M3 and M4 forms a current mirror circuit 10 and another pair of MOS transistors M1 and M2 forms a differential input pair 11. Each of the pairs of MOS transistors requires close matching respectively.

The most basic layout scheme to implement the current mirror circuit 10 is a lateral layout scheme. A better option is a common-centroid layout scheme. These layout schemes and a scheme called four-segment layout scheme are described in the following document.

20 Mao-Feng Lan, Anilkumar Tammineedi and Randall Geiger, "Current Mirror Layout Strategies for Enhancing Matching Performance", Analog Integrated Circuits and Signal Processing, vol. 28, PP. 9-26, July 2001.

These conventional layout schemes will be explained hereinafter. Fig. 8 shows the common-centroid layout scheme. Fig. 9 shows an equivalent circuit of Fig. 8. M1 and M2 are MOS field effect transistors that are to be matched. The transistor M1 is divided into two sub-transistors MS11 and MS21. Similarly, the transistor M2 is divided into two sub-transistors MS21 and MS22.

Since these sub-transistors have a common center P as shown in Fig. 8, it is called the common-centroid layout scheme. And gates, drains and sources of the sub-transistors MS11

and MS21 are connected in common to form the transistor M1, as shown in Fig. 9. Similarly, gates, drains and sources of the sub-transistors MS21 and M2S2 are connected in common to form the transistor M2.

And now, when the following document on transistor-matching and process-dependent layout structures is referred, transistors in various layouts are modeled.

M. J. M. Pelgrom, A. C. J. Duinmaijer and A. P. G. Welbers, "Matching properties of MOS transistors" IEEE JSSC, Vol. SC-24, PP. 1433-1439, 1989.

According to the document, an equivalent threshold voltage for such a device is given by the following equation.

$$V_{Teq} = \frac{\iint_{\text{active area}} V_T(x, y) \, dx dy}{\text{ActiveArea}}$$

Here, the Active Area denotes an active area of the sub-transistor, that is, a channel region through which a current flows. $V_T(x, y)$ is a local threshold voltage that depends on x and y coordinates. A surface integral of $V_T(x, y)$ over the active region is calculated to find its average.

And the threshold voltage varies from place to place on a surface of a wafer because of processing. Modeling of the variation in the threshold voltage is made possible by introducing a gradient amplitude α and a gradient direction θ from an origin O shown in Fig. 8.

Therefore, each of corresponding threshold voltages V_{T11} , V_{T12} , V_{T21} and V_{T22} can be obtained by applying such a threshold voltage model to each of the above mentioned sub-transistors MS11, MS12, MS21 and MS22, respectively.

First, the threshold voltage V_{T11} of the sub-transistor MS11 is given by the following equation.

$$V_{T11} = \frac{\int_{(L_S+d_2)}^{(2L_S+d_2)} \int_{(W_S+d_1)}^{(2W_S+d_1)} [V_T + (L_S \alpha \sin \theta) + (W_S \alpha \cos \theta)] \times [dW] \times [dL]}{W_S \times L_S}$$

$$\begin{aligned}
V_{T11} &= \frac{\int_{(L_S+d_2)}^{(2L_S+d_2)} \left[V_T W_S + L_S W_S \alpha \sin \theta + \alpha \cos \theta \left(\frac{(d_1 + 2W_S)^2 - (d_1 + W_S)^2}{2} \right) \right] [dL]}{W_S \times L_S} \\
V_{T11} &= \frac{\int_{(L_S+d_2)}^{(2L_S+d_2)} \left[V_T W_S + L_S W_S \alpha \sin \theta + \alpha \cos \theta \left(\frac{d_1^2 + 4W_S^2 + 4d_1 W_S - d_1^2 - W_S^2 - 2d_1 W_S}{2} \right) \right] [dL]}{W_S \times L_S} \\
V_{T11} &= \frac{\int_{(L_S+d_2)}^{(2L_S+d_2)} \left[V_T W_S + L_S W_S \alpha \sin \theta + \alpha \cos \theta \left(\frac{3W_S^2 + 2W_S d_1}{2} \right) \right] [dL]}{W_S \times L_S} \\
V_{T11} &= \frac{\int_{(L_S+d_2)}^{(2L_S+d_2)} \left[V_T + L_S \alpha \sin \theta + \alpha \cos \theta \left(\frac{3W_S}{2} + d_1 \right) \right] [dL]}{L_S} \\
5 \quad V_{T11} &= \frac{\left[V_T L_S + \alpha \cos \theta \left(\frac{3W_S}{2} + d_1 \right) L_S + \alpha \sin \theta \left(\frac{(2L_S + d_2)^2 - (L_S + d_2)^2}{2} \right) \right]}{L_S} \\
V_{T11} &= \frac{\left[V_T L_S + \alpha \cos \theta \left(\frac{3W_S}{2} + d_1 \right) L_S + \alpha \sin \theta \left(\frac{4L_S^2 + d_2^2 + 4L_S d_2 - L_S^2 - d_2^2 - 2L_S d_2}{2} \right) \right]}{L_S} \\
V_{T11} &= \frac{\left[V_T L_S + \alpha \cos \theta \left(\frac{3W_S}{2} + d_1 \right) L_S + \alpha \sin \theta \left(\frac{3L_S^2 + 2L_S d_2}{2} \right) \right]}{L_S} \\
V_{T11} &= V_T + \alpha \left(\frac{3W_S}{2} + d_1 \right) \cos \theta + \alpha \left(\frac{3L_S}{2} + d_2 \right) \sin \theta
\end{aligned}$$

Similarly, the threshold voltage V_{T12} of the sub-transistor MS12 is given by the following equation.

$$\text{MS12: } V_{T12} = V_T + \frac{W_S}{2} \alpha \cos \theta + \frac{L_S}{2} \alpha \sin \theta$$

Similarly, the threshold voltage V_{T21} of the sub-transistor MS21 is given by the following equation.

$$\text{MS21: } V_{T21} = V_T + \alpha \left(\frac{3W_s}{2} + d_1 \right) \cos \theta + \frac{L_s}{2} \alpha \sin \theta$$

Similarly, the threshold voltage V_{T22} of the sub-transistor MS22 is given by the following equation.

$$\text{MS22: } V_{T22} = V_T + \frac{W_s}{2} \alpha \cos \theta + \alpha \left(\frac{3L_s}{2} + d_2 \right) \sin \theta$$

5 In the equations described above, d_1 denotes a distance between drains (sources) of neighboring sub-transistors, d_2 denotes a distance between gates of neighboring sub-transistors, W_s denotes a width of the gate of the sub-transistor and L_s denotes a length of the gate of the sub-transistor.

Next, Fig. 10 shows the four-segment layout scheme. Fig. 11 shows an equivalent
10 circuit of Fig. 10. M1 and M2 are MOS field effect transistors that are to be matched. The transistor M1 is divided into four sub-transistors MS11, MS12, MS13 and MS14. These sub-transistors are disposed in four segments.

Similarly, the transistor M2 is divided into four sub-transistors MS21, MS22, MS23 and MS24. These sub-transistors are disposed in four segments.

15 An origin O, a gradient amplitude α and a gradient direction θ are also defined with respect to the four-segment layout scheme as shown in Fig. 10, and equations below that describe results of the modeling of the threshold values are obtained. That is, it is assumed in the following equations that a threshold value of the sub-transistor MS11 is V_{T11} , a threshold value of the sub-transistor MS12 is V_{T12} , a threshold value of the sub-transistor
20 MS13 is V_{T13} , a threshold value of the sub-transistor MS14 is V_{T14} , a threshold value of the sub-transistor MS21 is V_{T21} , a threshold value of the sub-transistor MS22 is V_{T22} , a threshold value of the sub-transistor MS23 is V_{T23} and a threshold value of the sub-transistor MS24 is V_{T24} .

$$\text{MS11: } V_{T11} = V_T - \alpha \left(\frac{W}{2} + \frac{d_1}{2} \right) \cos \theta + \alpha \left(\frac{L}{2} + W + \frac{3d_1}{2} \right) \sin \theta$$

$$25 \quad \text{MS12: } V_{T12} = V_T + \alpha \left(W + \frac{L}{2} + \frac{3d_1}{2} \right) \cos \theta + \alpha \left(\frac{W}{2} + \frac{d_1}{2} \right) \sin \theta$$

$$\text{MS13: } V_{T13} = V_T + \alpha \left(\frac{W}{2} + \frac{d_1}{2} \right) \cos \theta - \alpha \left(\frac{L}{2} + W + \frac{3d_1}{2} \right) \sin \theta$$

$$\text{MS14: } V_{T14} = V_T - \alpha \left(W + \frac{L}{2} + \frac{3d_1}{2} \right) \cos \theta - \alpha \left(\frac{W}{2} + \frac{d_1}{2} \right) \sin \theta$$

$$\text{MS21: } V_{T21} = V_T + \alpha \left(\frac{W}{2} + \frac{d_1}{2} \right) \cos \theta + \alpha \left(\frac{L}{2} + W + \frac{3d_1}{2} \right) \sin \theta$$

$$\text{MS22: } V_{T22} = V_T + \alpha \left(W + \frac{L}{2} + \frac{3d_1}{2} \right) \cos \theta - \alpha \left(\frac{W}{2} + \frac{d_1}{2} \right) \sin \theta$$

$$5 \quad \text{MS23: } V_{T23} = V_T - \alpha \left(\frac{W}{2} + \frac{d_1}{2} \right) \cos \theta - \alpha \left(\frac{L}{2} + W + \frac{3d_1}{2} \right) \sin \theta$$

$$\text{MS24: } V_{T24} = V_T - \alpha \left(W + \frac{L}{2} + \frac{3d_1}{2} \right) \cos \theta + \alpha \left(\frac{W}{2} + \frac{d_1}{2} \right) \sin \theta$$

In the equations described above, d_1 denotes a distance between drains (sources) of neighboring sub-transistors, W_s denotes a width of a gate of the sub-transistor and L_s denotes a length of the gate of the sub-transistor.

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DISCLOSURE OF THE INVENTION

The four-segment layout scheme described above can achieve better matching performance compared with the centroid layout scheme. However, the four-segment layout scheme has a drawback of requiring a large pattern area.

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Thus, a circuit layout configuration of this invention is a layout configuration in which a pair of transistors required close matching is divided into sub-transistors arrayed in a matrix with four rows and four columns forming four cells each composed of four sub-transistors, and the sub-transistors belonging to each cell have a common center, as shown in Fig. 1.

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This can realize a layout configuration that is as good in matching of the pair of transistors as the four-segment layout scheme and takes small pattern area.

BRIEF DESCRIPTION OF THE DRAWINGS

Fig. 1 is a plan view showing a multiple-common-centroid layout configuration

according to an embodiment of this invention. Fig. 2 is an equivalent circuit diagram of the multiple-common-centroid layout configuration according to the embodiment of this invention. Fig. 3 is a schematic diagram of the multiple-common-centroid layout configuration according to the embodiment of this invention. Fig. 4 is a circuit diagram of a circuit used for simulations of various kinds of layout. Fig. 5 shows results of simulations using HSPICE. Fig. 6 shows results of simulations using HSPICE. Fig. 7 is a circuit diagram showing a differential gain stage. Fig. 8 is a plan view showing a common-centroid layout scheme. Fig. 9 is an equivalent circuit diagram of the common-centroid layout scheme. Fig. 10 a plan view showing a four-segment layout scheme. Fig. 11 is an equivalent circuit diagram of the four-segment layout scheme.

BEST MODE FOR CARRYING OUT THE INVENTION

Next, an embodiment of this invention will be explained in detail, referring to figures. Fig. 1 shows a multiple-common-centroid layout configuration. Fig. 2 shows an equivalent circuit diagram of Fig. 1. M1 and M2 are MOS field effect transistors that are to be matched. The first transistor M1, that is a main-transistor, is divided into eight sub-transistors MS11, MS12, MS13, MS14, MS15, MS16, MS17 and MS18. Gates, drains and sources of these sub-transistors are connected in common to form the first transistor M1.

And similarly, the second transistor M2, that is a main-transistor, is also divided into eight sub-transistors MS21, MS22, MS23, MS24, MS25, MS26, MS27 and MS28. And gates, drains and sources of these sub-transistors are connected in common to form the second transistor M2.

The first transistor M1 and the second transistor M2 can form differential input pair transistors of a differential amplifier. And when a current mirror is formed with the first transistor M1 and the second transistor M2, the gates of the sub-transistors are connected in common with each other.

Above-mentioned 16 sub-transistors forming the first and second transistors M1 and M2 are arrayed in a matrix with four rows and four columns, when viewed as a whole. The matrix is formed of four cells. A first cell C1 is composed of the sub-transistors MS11 and

MS12 and the sub-transistors MS21 and MS22:

A second cell C2 is composed of the sub-transistors MS13 and MS14 and the sub-transistors MS23 and MS24. A third cell C3 is composed of the sub-transistors MS15 and MS16 and the sub-transistors MS25 and MS26. A fourth cell C4 is composed of the sub-transistors MS17 and MS18 and the sub-transistors MS27 and MS28.

To explain the first cell C1 in detail, the sub-transistor MS21 disposed at a first row and a first column, the sub-transistor MS22 disposed at a second row and a second column, the sub-transistor MS11 disposed at the first row and the second column and the sub-transistor MS12 disposed at the second row and the first column have a common center P1.

The sources and drains of these sub-transistors are arrayed parallel to a column direction while their gates are arrayed parallel to a row direction. And the second cell C2, the third cell C3 and the fourth cell C4 are formed with symmetrical configuration based on the first cell C1. Each of the second cell C2, the third cell C3 and the fourth cell C4 has each of common centers P2, P3 and P4, respectively.

Fig. 3 is a layout to explain a concept of the symmetrical configuration clearly. In the figure, the sub-transistors forming the first transistor M1 are marked with "1", and the sub-transistors forming the second transistor M2 are marked with "2". As seen from the figure, the second cell C2 is obtained by disposing the first cell C1 axisymmetrically (mirror symmetrically) with respect to a line of symmetry MR1. Also, the third cell C3 is obtained by disposing the first cell C1 axisymmetrically with respect to a line of symmetry MR2. The fourth cell C4 is obtained by disposing the second cell C2 axisymmetrically with respect to the line of symmetry MR2.

With that, a circuit layout configuration of the first transistor M1 and the second transistor M2 is obtained. When it is defined as a macro cell MC1, a macro cell MC2 that is axisymmetrical with respect to a line of symmetry MR3 is obtained based on the macro cell MC1. And a macro cell MC3 and a macro cell MC4, that are axisymmetrical with respect to a line of symmetry MR4, can be further obtained based on the macro cells MC1 and MC2.

Furthermore, a macro cell that is not shown in the figure can be obtained by disposing the macro cells MC1, MC2, MC3 and MC4 with respect to a line of symmetry MR5. Macro

cells can be increased indefinitely by repeating such symmetrical configuration.

Next, when the threshold voltage model described above is applied to the 16 sub-transistors mentioned above, a threshold value for each of the sub-transistors is given by each of the following equations. An origin O, a gradient amplitude α and a gradient direction θ are defined in Fig. 1.

$$\text{MS11: } V_{T11} = V_T + \alpha \left(\frac{3W_s}{2} + d_1 \right) \cos \theta + \alpha \left(\frac{7L_s}{2} + 2d_2 + d_3 \right) \sin \theta$$

$$\text{MS12: } V_{T12} = V_T + \frac{W_s}{2} \alpha \cos \theta + \alpha \left(\frac{5L_s}{2} + d_2 + d_3 \right) \sin \theta$$

$$\text{MS13: } V_{T13} = V_T + \alpha \left(\frac{5W_s}{2} + 2d_1 \right) \cos \theta + \alpha \left(\frac{7L_s}{2} + 2d_2 + d_3 \right) \sin \theta$$

$$\text{MS14: } V_{T14} = V_T + \alpha \left(\frac{7W_s}{2} + 3d_1 \right) \cos \theta + \alpha \left(\frac{5L_s}{2} + d_2 + d_3 \right) \sin \theta$$

$$10 \quad \text{MS15: } V_{T15} = V_T + \frac{W_s}{2} \alpha \cos \theta + \alpha \left(\frac{3L_s}{2} + d_2 \right) \sin \theta$$

$$\text{MS16: } V_{T16} = V_T + \alpha \left(\frac{3W_s}{2} + d_1 \right) \cos \theta + \frac{L_s}{2} \alpha \sin \theta$$

$$\text{MS17: } V_{T17} = V_T + \alpha \left(\frac{7W_s}{2} + 3d_1 \right) \cos \theta + \alpha \left(\frac{3L_s}{2} + d_2 \right) \sin \theta$$

$$\text{MS18: } V_{T18} = V_T + \alpha \left(\frac{5W_s}{2} + 2d_1 \right) \cos \theta + \frac{L_s}{2} \alpha \sin \theta$$

$$\text{MS21: } V_{T21} = V_T + \frac{W_s}{2} \alpha \cos \theta + \alpha \left(\frac{7L_s}{2} + 2d_2 + d_3 \right) \sin \theta$$

$$15 \quad \text{MS22: } V_{T22} = V_T + \alpha \left(\frac{3W_s}{2} + d_1 \right) \cos \theta + \alpha \left(\frac{5L_s}{2} + d_2 + d_3 \right) \sin \theta$$

$$\text{MS23: } V_{T23} = V_T + \alpha \left(\frac{7W_s}{2} + 3d_1 \right) \cos \theta + \alpha \left(\frac{7L_s}{2} + 2d_2 + d_3 \right) \sin \theta$$

$$\text{MS24: } V_{T24} = V_T + \alpha \left(\frac{5W_s}{2} + 2d_1 \right) \cos \theta + \alpha \left(\frac{5L_s}{2} + d_2 + d_3 \right) \sin \theta$$

$$\text{MS25: } V_{T25} = V_T + \alpha \left(\frac{3W_s}{2} + d_1 \right) \cos \theta + \alpha \left(\frac{3L_s}{2} + d_2 \right) \sin \theta$$

$$\text{MS26: } V_{T26} = V_T + \frac{W_s}{2} \alpha \cos \theta + \frac{L_s}{2} \alpha \sin \theta$$

$$\text{MS27: } V_{T27} = V_T + \alpha \left(\frac{5W_s}{2} + 2d_1 \right) \cos \theta + \alpha \left(\frac{3L_s}{2} + d_2 \right) \sin \theta$$

$$\text{MS28: } V_{T28} = V_T + \alpha \left(\frac{7W_s}{2} + 3d_1 \right) \cos \theta + \frac{L_s}{2} \alpha \sin \theta$$

5 In the equations described above, d_1 denotes a distance between drains (sources) of neighboring sub-transistors, d_2 and d_3 denote distances between gates of neighboring sub-transistors, W_s denotes a width of the gate of the sub-transistor and L_s denotes a length of the gate of the sub-transistor.

Next, simulations using HSPICE are explained. An aim of the simulations is to check
 10 performance of various transistor-matching layouts with respect to change in the gradient direction θ . Parameters common to all the simulations are, $d_1 = d_2 = d_3$
 $4 \mu\text{m}$, $\alpha = 0.5 \text{ mV}/\mu\text{m}$, $V_T = 0.7\text{V}$

Fig. 4 shows a circuit diagram of a circuit used for the simulations. A first transistor M_1 , that is a main-transistor, is divided into N sub-transistors $MS11 - MS1N$, and a bias
 15 voltage V_B is applied to their gates in common. And a high power supply V_{dd} is applied to a common drain $D1$ of the sub-transistors $MS11 - MS1N$ through a resistor R . And a low power supply V_{ss} is applied to a common source $S1$ of the sub-transistors $MS11 - MS1N$.

A second transistor M_2 , that is a main-transistor, is divided into N sub-transistors $MS21 - MS2N$, and a bias voltage V_B is applied to their gates in common. And the high
 20 power supply V_{dd} is applied to a common drain $D2$ of the sub-transistors $MS21 - MS2N$ through a resistor R . And the low power supply V_{ss} is applied to a common source $S2$ of the sub-transistors $MS21 - MS2N$.

Here, for all the simulations performed, a percent mismatch is defined by the following equation.

$$\text{Percent Mismatch} = \frac{I_{M2} - I_{M1}}{I_{M1}} \times 100$$

Here, I_{M1} denotes a current flowing through the first transistor M1 and I_{M2} denotes a current flowing through the second transistor M2. Two sets of simulations are performed to compare the performance of the different transistor-matching layouts. In a first set, sizes of the sub-transistors are set as $W_s = 10 \mu\text{m}$ and $L_s = 10 \mu\text{m}$ for all the layout schemes.

Thus, widths W and lengths L for various layout schemes are as follows.

common-centroid layout:	$W = 20 \mu\text{m}$	$L = 10 \mu\text{m}$
four-segment layout:	$W = 40 \mu\text{m}$	$L = 10 \mu\text{m}$
multiple-common-centroid layout:	$W = 80 \mu\text{m}$	$L = 10 \mu\text{m}$

Fig. 5 shows simulation results for the first set of simulations. A horizontal axis shows the gradient direction θ , while a vertical axis shows the percent mismatch (%). As clearly seen from the results, the multiple-common-centroid layout of this invention shows an improvement in the matching performance comparable to the common-centroid layout. That is, the percent mismatch (%) for the multiple-common-centroid layout is three orders smaller than that for the common-centroid layout.

A second set of the simulation is performed under conditions that sizes of the first transistor M1 and the second transistor M2 are same for all the layout schemes. That is, the width W is $80 \mu\text{m}$ and the length W is $10 \mu\text{m}$ for the first transistor M1 and for the second transistor M2. Thus, dimensions of the sub-transistors for various layout schemes are as follows.

common-centroid layout:	$W_s = 40 \mu\text{m}$	$L_s = 10 \mu\text{m}$
four-segment layout:	$W_s = 20 \mu\text{m}$	$L_s = 10 \mu\text{m}$
multiple-common-centroid layout:	$W_s = 10 \mu\text{m}$	$L_s = 10 \mu\text{m}$

Fig. 6 shows simulation results for the second set of simulations. A horizontal axis shows the gradient direction θ , while a vertical axis shows the percent mismatch (%). The percent mismatch (%) for the multiple-common-centroid layout of this invention is improved compared with either of the other layouts, as the results clearly show.

Also, the multiple-common-centroid layout of this invention has a feature that it takes

less layout area compared with the four-segment layout. Effect of the improvement in the matching by the multiple-common-centroid layout can be achieved at slightly more layout area requirement compared to the common-centroid layout.

A table on the next page shows formulae to calculate areas for three different layout schemes and the calculated areas for a given set of parameters. Dimensions of the first transistor M1 and the second transistor M2, that are main-transistors, are the width $W = 80 \mu\text{m}$ and the length $L = 10 \mu\text{m}$ with $d_1 = d_2 = d_3 = 4 \mu\text{m}$ for all the layout schemes.

For the common-centroid layout, each of the main-transistors is divided into two sub-transistors. The width W_s is $40 \mu\text{m}$ and the length L_s is $10 \mu\text{m}$ for each of the sub-transistors. For the four-segment layout, each of the main-transistors is divided into four sub-transistors. The width W_s is $20 \mu\text{m}$ and the length L_s is $10 \mu\text{m}$ for each of the sub-transistors.

For the multiple-common-centroid layout of this invention, each of the main-transistors is divided into eight sub-transistors. The width W_s is $10 \mu\text{m}$ and the length L_s is $10 \mu\text{m}$ for each of the sub-transistors.

Table

Layout Type	Area Estimation Formulae*	Calculated Area* [$W=80\mu\text{m}$, $L=10\mu\text{m}$ $d_1=d_2=d_3=4\mu\text{m}$]
Common-Centroid	$(2L_s+d_2)(2W_s+d_1)$	$2.016\text{e-}9\text{m}^2$ [$W_s=40\mu\text{m}$, $L_s=10\mu\text{m}$]
Four-Segmented	$(2W_s+2L_s+3d_1)(2W_s+2L_s+3d_1)$	$5.184\text{e-}9\text{m}^2$ [$W_s=20\mu\text{m}$, $L_s=10\mu\text{m}$]
Multiple-Common-Centroid	$(4L_s+2d_2+d_3)(4W_s+3d_1)$	$2.704\text{e-}9\text{m}^2$ [$W_s=10\mu\text{m}$, $L_s=10\mu\text{m}$]

* L_s and W_s represent the dimensions of the sub-transistors.

* L and W represent the dimensions of the main-transistors.

As described above, the multiple-common-centroid layout of this invention has the effect that the matching performance comparable to the four-segment layout can be obtained while the layout area can be made small.

In particular, a low offset operational amplifier can be realized by applying the layout of
5 this invention to a differential transistor pair and a transistor pair forming a current mirror of the operational amplifier.